

საქართველოს სტანდარტი

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ლაქ-საღებავები - ფენის სისქის განსაზღვრა

საინფორმაციო ნაწილი. სრული ტექსტის სანახავად შეიძინეთ სტანდარტი.

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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see www.iso.org/directives).

Attention is drawn to the possibility that some of the elements of this document may be the subject of patent rights. ISO shall not be held responsible for identifying any or all such patent rights. Details of any patent rights identified during the development of the document will be in the Introduction and/or on the ISO list of patent declarations received (see www.iso.org/patents).

Any trade name used in this document is information given for the convenience of users and does not constitute an endorsement.

For an explanation of the voluntary nature of standards, the meaning of ISO specific terms and expressions related to conformity assessment, as well as information about ISO's adherence to the World Trade Organization (WTO) principles in the Technical Barriers to Trade (TBT) see www.iso.org/iso/foreword.html.

This document was prepared by Technical Committee ISO/TC 35, *Paints and varnishes*, SC 9, *General test methods for paints and varnishes*.

This fifth edition cancels and replaces the fourth edition (ISO 2808:2007), which has been technically revised. The main changes compared to the previous edition are as follows:

- the terms and definitions have been updated to ISO 4618 and ISO/IEC Guide 99;
- the principle has been revised;
- white-light interferometer has been added as method 6C;
- the terahertz method has been added as method 11;
- the existing methods have been adapted to the current state of metrology;
- the characterisation of the methods and procedures in [Annex A](#) have been revised;
- information in [Annex A](#) on the precision of the individual methods has been adapted to current standards;
- the references to test standards and constructions standards in [Annex A](#) have been updated;
- former Clause 7 on measurement of the film thickness on rough surfaces has been moved to [Annex B](#);
- [Annex C](#), on factors which influence measuring accuracy when measurements are performed on wood has been added.

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at www.iso.org/members.html.

Introduction

This document consistently enumerates the individual coatings applied in a multi-layer system by referring to the first coating applied on the substrate as coating 1. Some other standards referring to individual test methods enumerate in reverse order.